





12th European Seminar on Precision Optics Manufacturing, May 6th - 7th 2025 Deggendorf Institute of Technology Technology Campus Teisnach Optics, Germany

Main topics

- Manufacturing and measurement of optics from mm- to m-range and optical systems: Processes for grinding, polishing, centering, assembly, handling, surface modification, cleaning and coating of optics
- Standards in optics manufacturing. Design of optics, error budgeting, fusion of optical and mechanical design, strategies for optical design within mechanical tolerances. Optical design SW: experiences, current developments, license models & alternatives
- Advanced and next generation technologies in high precision manufacturing: Ultraprecision machining, kinetic abrasive polishing, additive manufacturing, molding, new and special materials, next generation of giant optics manufacturing and testing
- Smart fusion of manufacturing and measurement of optics: Lessons learned in industry and research institutes in environment, media control, process stability, measurement, data handling and data mining
- Internet of things: Data handling and security within the value chain from optical design to manufacturing process, optical systems and their integrity and vulnerabilities

Conference language:

English

We are looking forward to meeting you at the 12th European Seminar on Precision Optics Manufacturing.

Yours sincerely,

Prof. Waldemar Berg

Prof. Dr. Gerald Fütterer

Gerald Outher



Chairs: Dr. Oliver Fähnle, PanDao GmbH

Prof. Dr. Gerald Fütterer, DIT

Prof. Dr. Ing. Christine Wünsche, DIT

Prof. Dr. Helge Thieß, DIT

1ST DAY, TUESDAY, MAY 6TH 2025

9:30 CHECK-IN

10:15 WELCOME

10:20 SESSION 1 - NON-GLASS MATERIALS - NEW MATERIALS FOR

OPTICAL APPLICATIONS

Growth of Oxide- and Fluoride Crystals and Preparation of Photonic Components

Dr. Thomas Straubinger, Leibniz-Institut für Kristallzüchtung (IKZ), D

Extreme Lightweighted Ceramic Mirrors for Future Science and Earth

Observation Missions

Matthias R. Kroedel, ECM Engineered Ceramic Materials GmbH, D

11:00 SESSION 2 - METROLOGY AND SIMULATION

Absolute position information to reduce uncertainty in flexible asphere and

freeform metrology

Cristof Pruss, University of Stuttgart Institute of Applied Optics (ITO), D

Vignetting as a physical measuring principle for the characterization of aspheres

Dr. Engelbert Hofbauer, HOFBAUER OPTIK Mess- & Prüftechnik, D

Modeling and optical simulation of the V-spot sensor in Zemax OpticStudio

Michael Wagner, Deggendorf Institute of Technology, D

Translating Optical Design Specifications into Manufacturing Terminology:

Bridging the Gap Between Designers and Manufacturers

Thomas Pickering, ANSYS Germany GmbH, D

12:30 LUNCH

13:30 - 17:30 BAYERN PHOTONICS AND POSTER SESSION

15:30 COFFEE BREAK



17:30 LAB TOUR

18:30 GET2GETHER - BAVARIAN EVENING

2ND DAY, WEDNESDAY, MAY 7TH 2025

9:00 SESSION 3 - GRINDING

Ultra-precision grinding of MAX-phase-composites

Dennis Wilhelm, Manufacturing Technology Institute (MTI), RWTH Aachen, D

High-precision machining of optical components - Importance of the coolant supply Bernhard Welle, Turbo-Separator AG, CH

Subsurface Damage Characterization in Fused Silica: Influence of Surface Quality Assessed by Optical Coherence Topography

Dennis Thelemann, EAH Jena, D

Ultra-precision grinding of large optics on the UPG 1000 CNC

Dr. Lars Schönemann, OptoTech, D

10:30 COFFEE BREAK

11:30 SESSION 4 - POLISHING, AUTOMATION AND ASSEMBLY

Advancements in Optics Manufacturing: Five-Dimensional Bonding of Multi-Element Assemblies within a Single Barrel

Dr. Patrik Langehanenberg, Trioptics, D

Investigation of Slurry Aggregation Effects on CMP Process with Electrical Power Sensor Utilization

Farouq Abbas, Technische Universität Ilmenau, D

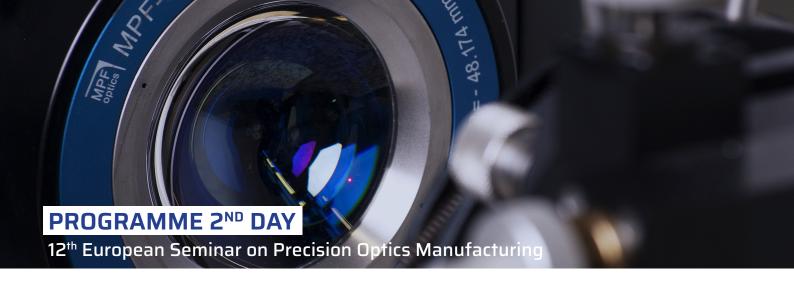
Integration of sensors in manufacturing processes - SensAPro

Michael Benisch, Deggendorf Institute of Technology, D

Optimization of Optical Surfaces For High Energy Beam Delivery And Beam Shaping Micro-Optics

Dirk Hauschild, Focuslight Technologies Inc., D

13:00 LUNCH



14:00 SESSION 5 - NEXT GENERATION MANUFACTURING

Determination of SSD depth applying atmospheric plasma jet and ion beam *Heike Müller, Leibniz-institute of Surface Engineering (IOM), D*

Laser polishing - a way to influence glass surfacesSusanne Kasch, Günter Köhler Institute for Joining Technology and Materials
Testing (ifw Jena), D

Laser-based manufacturing of fused silica optics Emrah Uluz, Fraunhofer Institute for Laser Technology ILT, D

Stability of masking materials for pattern transfer of lithographic masks into fused silica by atmospheric pressure plasma jet etching

Robert Heinke, Leibniz-institute of Surface Engineering (IOM), D

15:30 END OF THE SEMINAR